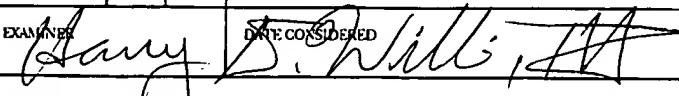


Form PTO-1049 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 10-5004(4015)		SERIAL NO. 09/465,402		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Vladimir Segal et al.		
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						Yes No
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	AI					
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
HW	AK		F. J. Humphreys et al., "Developing stable fine-grain microstructures by large strain deformation", Phil. Trans. R. Soc. Lond. A, June 15, 1999, Vol. 357 #1756, pp. 1663-1681.			
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Larry D. Wilk		1/18/05				
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	AE						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
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